



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takunori IKI et al.

Group Art Unit: 2812

Application No.: 10/633,682

Examiner: A. Ghyka

Filed: August 5, 2003

Docket No.: 116507

For: SYSTEM AND METHOD OF MANUFACTURING A SUBSTRATE DEVICE

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the January 26, 2006 Office Action, reconsideration based on the following remarks is respectfully requested. Claims 1, 3-13 and 15 are pending.

I. Claims Define Allowable Subject Matter

The Office Action rejects claims 1, 3-13 and 15 under the judicially created doctrine of obviousness-type double patenting as unpatentable over claims 1-21 of U.S. Patent Application No. 10/690,270. A Terminal Disclaimer is attached to obviate the rejection. Withdrawal of the obviousness-type double patenting rejection is respectfully requested.

Also, Applicants respectfully traverse the Examiner's characterization of the 270 application claims. Specifically, the Examiner asserts that the 270 application claims require thin film transistors, a nitride film comprising an aperture, and an electrode above and below the nitride film. However, none of the 270 application claims include these features.